## Notice of References Cited Application/Control No. O9/697,146 Examiner Qi Han Applicant(s)/Patent Under Reexamination YAMAGISHI ET AL. Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,946,658 A	08-1999	Miyazawa et al.	704/275
	В	US-6,505,162 B1	01-2003	Wang et al.	704/275
	С	US-6,173,266 B1	01-2001	Marx et al.	704/270
	D	US-6,185,527 B1	02-2001	Petkovic et al.	704/231
	E	US-6,236,968 B1	05-2001	Kanevsky et al.	704/275
	F	US-5,577,165 A	11-1996	Takebayashi et al.	704/275
	G	US-6,584,439 B1	06-2003	Geilhufe et al.	704/270
	Н	US-5,748,841	05-1998	Morin et al.	704/257
	ı	US-6,446,076 B1	09-2002	Burkey et al.	707/102
	J	US-6,408,272 B1	06-2002	White et al.	704/270.1
	к	US-6,330,539 B1	12-2001	Takayama et al.	704/275
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Φ.					
	σ	_				
	R					
	Ø					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.